

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kevin J. Orvek et al. Art Unit : 2823
Serial No. : 10/814,883 Examiner : Jarrett J. Stark
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Title : REAL-TIME MONITORING OF PARTICLES IN SEMICONDUCTOR
VACUUM ENVIRONMENT

Mail Stop Express Abandonment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

EXPRESS ABANDONMENT UNDER 37 CFR §1.138

Applicant hereby expressly abandons application serial number 10/814,883, filed March 31, 2004 in favor of co-pending application serial numbers 11/773,197 and 11/773,220, filed July 3, 2007, which are directed to the same subject matter. This abandonment is made without prejudice and is not intended as an abandonment of the subject matter disclosed and claimed in this application.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date:

July 9, 2007



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